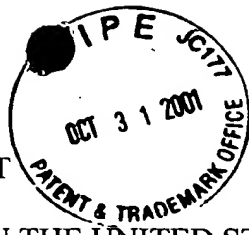


194310US2PCT



IN THE UNITED STATES PATENT & TRADEMARK OFFICE

7/B Amold  
11/8/01  
A. Waller

IN RE APPLICATION OF: :  
Lea DI CIOCCIO : EXAMINER: EVERHART, C  
SERIAL NO: 09/582,630 :  
FILED: JULY 26, 2000 : GROUP ART UNIT: 2825  
FOR: PROCESS FOR FABRICATING A STRUCTURE  
OF SEMICONDUCTOR-ON-INSULATOR TYPE,  
IN PARTICULAR SiCOI

TECHNOLOGY CENTER 2000  
11-8-2001  
PROCESSED

AMENDMENT

ASSISTANT COMMISSIONER FOR PATENTS  
WASHINGTON, D.C. 20231

SIR:

In response to the Office Action dated May 31, 2001, please amend the above-identified application as follows:

IN THE TITLE

Please change the title in the PTO database to reflect the title, as shown in the Declaration and the first page of the specification, which is:

PROCESS FOR FABRICATING A STRUCTURE OF  
SEMICONDUCTOR-ON-INSULATOR TYPE, IN PARTICULAR SiCOI

B